



MIT9922

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Menon et al. **GROUP:** 2881
SERIAL NO: 10/624,316 **EXAMINER:** Berman, Jack I.
FILED: 07/21/2003
FOR: SYSTEM AND METHOD FOR MASKLESS LITHOGRAPHY USING
AN ARRAY OF IMPROVED DIFFRACTIVE FOCUSING ELEMENT

Mail Stop RCE
Assistant Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Responsive to the Final Office Action mailed on January 27, 2005, and in connection with the Request for Continued Examination filed herewith, please amend the above-identified application as follows: